

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION OF

Inventor(s): TSUJI, Akitoshi et al

Filed: Herewith

Title: MANAGING APPARATUS AND MANAGING METHOD OF A SEMICONDUCTOR  
MANUFACTURING APPARATUS

June 22, 2001

**PRELIMINARY AMENDMENT**

Hon. Commissioner of Patents  
Washington, D.C. 20231

Sir:

Please amend this application as follows:

**IN THE SPECIFICATION:**

At the top of the first page, just under the title, insert:

1. ☐ --This is a ☐ Continuation-In-Part ☐ Divisional  
☒ Continuation ☐ Substitute Application (MPEP 201.09) of  
 1(a) ☐ National Application No. \_\_\_\_/\_\_\_\_ filed \_\_\_\_\_.  
 1(b) ☒ International Application No. PCT/JP01/04318  
 filed May 23, 2001 which designated the U.S.--
2. ☐ --This application claims the benefit of U.S. Provisional Application No.  
 60/\_\_\_\_, filed \_\_\_\_\_.--

Respectfully submitted,

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